

## ARTICLE OPEN



# Unconventional conductivity increase in multilayer black phosphorus

Maria Kolešnik-Gray<sup>1</sup>, Laura Meingast<sup>1</sup>, Martin Siebert<sup>1</sup>, Tim Unbehaun<sup>1</sup>, Tobias Huf<sup>1</sup>, Günter Ellrott<sup>1</sup>, Gonzalo Abellán<sup>1,2,3</sup>, Stefan Wild<sup>2</sup>, Vicent Lloret<sup>2</sup>, Udo Mundloch<sup>2</sup>, Julian Schwarz<sup>1,4</sup>, Michael Niebauer<sup>1,4</sup>, Maximilian Szabo<sup>1,4</sup>, Mathias Rommel<sup>1,5</sup>, Andreas Hutzler<sup>1,6</sup>, Frank Hauke<sup>2</sup>, Andreas Hirsch<sup>1,2</sup> and Vojislav Krstić<sup>1</sup>✉

Multilayers of so-called 2D van der Waals materials have gained considerable attention as active components of next-generation electronic and optoelectronic technologies, with semiconducting black phosphorus (BP) regarded as one of the most promising systems. The applicability and performance limits of BP in both stand-alone and heterostructure-based multilayer devices are determined by individual flake charge transport properties, which synergistically depend on the number of layers and the strength of interlayer coupling between those. In this work, we study the DC electrical transport characteristics of high-quality BP field-effect devices within a wide range of flake thicknesses at room temperature. The experimental data show a non-trivial increase in conductivity and hole density with a reduced number of layers while maintaining constant field-effect mobility due to the prevalence of electron-phonon scattering. Based on the solution of the 1D Schrödinger–Poisson equation, we find that the observed phenomena are a direct consequence of non-negligible interlayer coupling, which in turn causes a local redistribution of free charge carriers towards the central layers. Our data show that due to the electrostatic conditions at the flake surfaces, a naturally protected 2D hole gas can be encapsulated in flakes as high as 10 nm, which preserves the bulk-like bandgap and effective carrier masses due to the electrostatic environment.

*npj 2D Materials and Applications* (2023)7:21 | <https://doi.org/10.1038/s41699-023-00384-2>

## INTRODUCTION

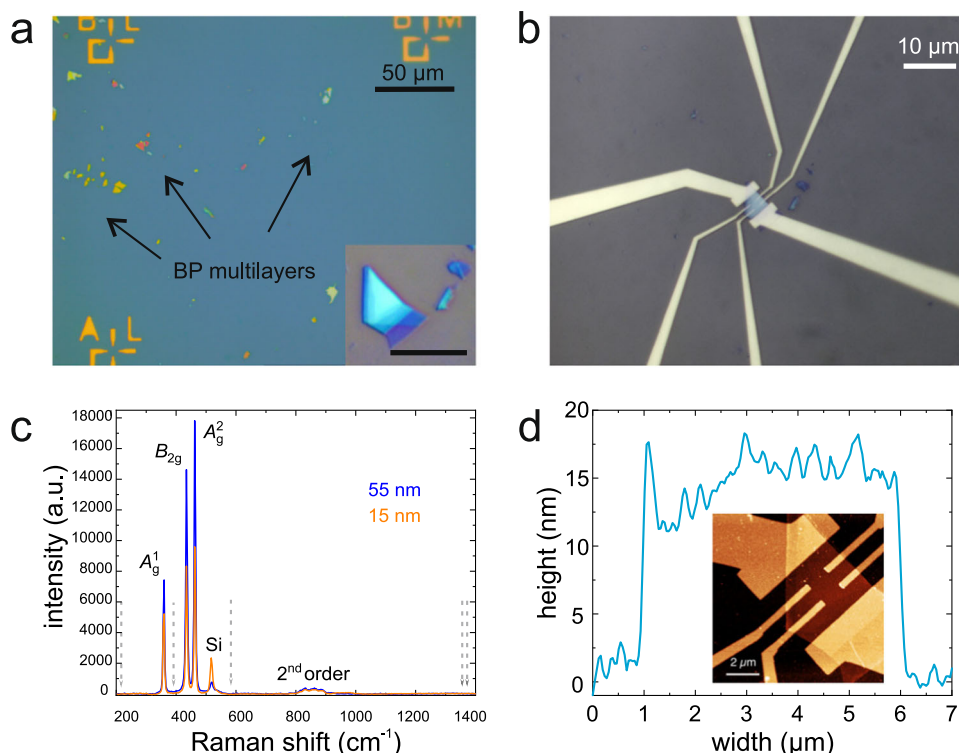
Black phosphorus (BP) is a synthetically derived layered semiconductor material<sup>1</sup> representing a class of monoatomic so-called two-dimensional (2D) van der Waals materials<sup>2,3</sup>. The individual layers which form BP—phosphorene—have a puckered hexagonal structure<sup>4</sup> and are bound together by *both* van der Waals and ionic forces<sup>5,6</sup>. As-grown (undoped) BP crystals are hole conductors<sup>7,8</sup> with distinctive anisotropy of electrical transport properties along the principal axis<sup>8</sup>. The *p*-type character of the majority of charge carriers has been attributed to the presence of electron trapping sites within the crystal lattice<sup>9,10</sup>.

Monolayer phosphorene, in particular, has been identified as one of the most promising 2D electronic materials<sup>11–13</sup>. Its semiconducting properties, including a bandgap comparable to silicon<sup>14</sup> and theoretically predicted hole mobility in the 10<sup>3</sup> cm<sup>2</sup>/Vs range<sup>15</sup>, is expected to significantly boost the electrical conduction and switching properties of associated phosphorene field-effect transistor devices regardless of their actual (effective) carrier concentration or their spatial distribution within the system. On the other hand, few-layer components, which constitute the vast majority of experimental data reported in the literature, present a higher degree of structural—and thus electronic—complexity. In particular, the overlap of the electronic wavefunctions between individual phosphorene layers<sup>5,6</sup> is non-negligible, therefore, black phosphorus is not a pure van der Waals system. This is also reflected by the three to ten times larger layer-to-layer binding energy compared to graphene and MoS<sub>2</sub>, respectively

(Supporting Information). Consequently, such non-negligible interaction also facilitates some charge carrier transfer between the neighbouring 2D sheets while simultaneously preserving the preferential motion of carriers within individual layers under applied in-plane external electric fields. Therefore, the question of how the thickness of a multi-layered BP system affects the spatial distribution of free charge carriers and, consequently, its overall electrical conduction properties becomes highly relevant, not only from the fundamental but also application viewpoint. In particular, the layer number dependent charge transport efficacy will strongly impact the performance of BP-based photodetectors<sup>16,17</sup>, photocatalysts<sup>18</sup>, energy conversion and storage devices<sup>19,20</sup>, biomedical devices and sensors<sup>21</sup>.

In the present work, we demonstrate through a comprehensive experimental study that the room temperature electrical conductivity of BP outside of the band-gap opening layer range reveals an unexpected regime of unconventional increase as the number of layers is reduced. Considering BP in this layer range in electrical terms to be a simple small-sized bulk semiconductor, such an increase is contrary to the expectation—a continuous reduction of size should lead to a decrease of conductivity upon height (layer number) reduction. The here observed conductivity augmentation is intimately connected to an increase in the effective carrier density in the flakes while charge-carrier mobility remains constant. Using a simple 3D-semiconductor description, we find that the experimentally observed effects can be explained by local charge redistribution towards the central

<sup>1</sup>Department of Physics, Friedrich-Alexander-Universität Erlangen-Nürnberg (FAU), Staudtstr. 7, 91058 Erlangen, Germany. <sup>2</sup>Department of Chemistry and Pharmacy and Joint Institute of Advanced Materials and Processes (ZMP), Friedrich-Alexander University of Erlangen-Nürnberg (FAU), Nikolaus-Fiebiger-Str. 10, 91058 Erlangen, Germany. <sup>3</sup>Instituto de Ciencia Molecular, Universidad de Valencia, Catedrático José Beltrán 2, 46980 Paterna, Spain. <sup>4</sup>Electron Devices (LEB), Department of Electrical Engineering, Friedrich-Alexander-Universität Erlangen-Nürnberg (FAU), Cauerstraße 6, 91058 Erlangen, Germany. <sup>5</sup>Fraunhofer Institute for Integrated Systems and Device Technology IISB, Schottkystraße 10, 91058 Erlangen, Germany. <sup>6</sup>Forschungszentrum Jülich GmbH, Helmholtz Institute Erlangen-Nürnberg for Renewable Energy (IEK-11), Cauerstraße 1, 91058 Erlangen, Germany. ✉email: [vojislav.krstic@fau.de](mailto:vojislav.krstic@fau.de)



**Fig. 1 Mechanical exfoliation and electrical contacting of multilayer BP.** Exemplary optical micrographs of **a** BP flakes transferred onto the SiO<sub>2</sub>-coated silicon substrate. Inset: single BP flake (scale bar 10 μm). **b** A flake after electrical contact with Ti/Au electrodes in a 4-point configuration. Large electrodes are current-carrying leads, side electrodes are 4-point voltage probes (cf. “Methods”). **c** Raman spectrum of two flakes of different thicknesses after device processing. Only the common BP signature lines A<sub>g</sub><sup>1</sup>, B<sub>2g</sub> and A<sub>g</sub><sup>2</sup> and the intrinsic BP second-order Raman response (ca. 790–920 nm<sup>-1</sup> range) are observed (Si line from the substrate as expected at 520 cm<sup>-1</sup>). No trace of other lines associated with oxidation or degradation is present. The expected positions of theoretically predicted prominent oxidation lines are indicated by the arrows<sup>28,29</sup>. **d** Flake height profile extracted from an atomic force micrograph (inset) after electrical characterisation. The extracted flake height is (15.1 ± 1.8) nm corresponding to (29 ± 3) phosphorene layers.

layers due to surface electrostatic conditions. Our results also provide insight into resolving the in-literature experimentally observed mobility limit of ~300 cm<sup>2</sup>/Vs in few-layer BP devices at room temperature<sup>22–25</sup>.

## RESULTS AND DISCUSSION

### Sample contacting, Raman and AFM characterisation

BP flakes were exfoliated from bulk crystals on the substrate and immediately capped with PMMA, both under an inert atmosphere (cf. “Methods” section). Optical images of PMMA capped exemplary flakes are shown in Fig. 1a. After identification of flakes, Ti/Au electrodes were electron-beam-lithographically defined on top (cf. “Methods” section), resulting in devices as shown in Fig. 1b. Immediately after electrode definition the devices were again covered by a protective PMMA layer. For further characterisation, Raman spectroscopy was carried out (cf. “Methods” section) on fully processed devices, revealing a spectrum as shown in Fig. 1c. The spectrum shows only the well-known intrinsic first (A<sub>g</sub><sup>1</sup>, B<sub>2g</sub> and A<sub>g</sub><sup>2</sup>) and second order (ca. 790–920 nm<sup>-1</sup> range) Raman signatures<sup>26,27</sup>, while there is no trace of lines associated with oxidation<sup>28,29</sup> or any other uncommon lines discernible. Combined, the presence of the two intrinsic Raman responses and the absence of any other signs indicative of oxidation or degradation shows that the BP processed into devices is free of any unintentional influences.

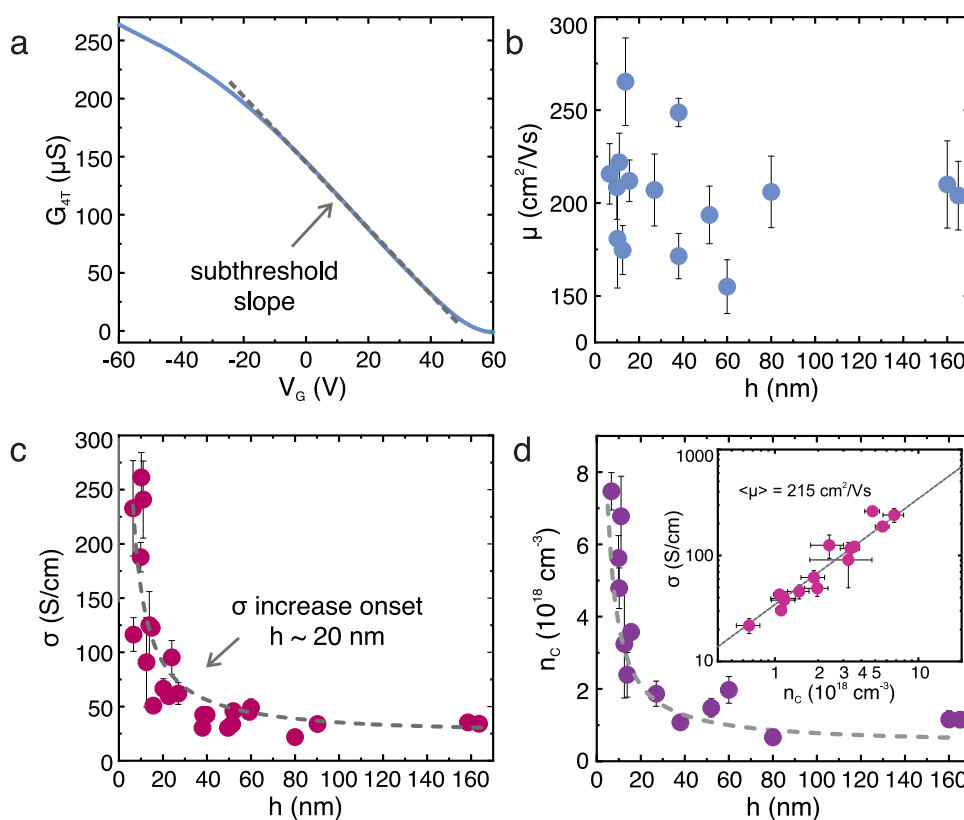
This is further supported by AFM characterisation (cf. “Methods”) of our processed devices from which we also extracted the height of the samples (Fig. 1d). Regarding the latter, the height range of the electrically characterised flakes ranged from ca. 6 nm

up to 160 nm. That is, the thinnest flakes characterised were still beyond the bandgap broadening limit<sup>14</sup>. Also, our AFM imaging directly after electrical measurements (after PMMA removal) did not show any discernible blistering associated with BP flake degradation (Fig. 1d inset), in agreement with the Raman findings. Specifically, the data analysis revealed root mean square (RMS) values consistent with the absence of any relevant surface oxidation or degradation in general (Supporting Information) in agreement with previous AFM studies<sup>30</sup>.

### Layer-dependent charge transport properties

Electrical measurements were carried out in a four-point configuration at room temperature and under DC conditions. The highly doped silicon substrate (300 nm SiO<sub>2</sub> gate dielectric on top) served as a global back-gate for transfer characteristic measurements. In-plane-orientation selection of the flakes was discarded as experimental evidence showed that the conductivity and mobility of BP flakes in armchairs and in zigzag direction differ at room temperature by less than a factor of 1.6<sup>11</sup>. All devices showed linear two-point current–voltage (*I*–*V*) characteristics demonstrating low contact resistance and ohmicity of the electrode/BP interface (cf. Supporting Information).

In all devices studied, unipolar *p*-type field switching behaviour was observed, with weak on/off switching for gate bias exceeding ±60 V (Fig. 2a). The hole mobilities,  $\mu$ , extracted from the linear part of the subthreshold slope were found to be largely independent of the flake height (as corroborated by Hall measurements, see Supporting Information), and to lie around 200 cm<sup>2</sup>/Vs (Fig. 2b), which is in agreement with the majority of earlier experimental studies<sup>22–25</sup>.



**Fig. 2 Height-dependent electronic properties of BP flakes at room temperature.** **a** Representative four-point field-effect characteristic of a BP flake showing unipolar *p*-type behaviour and weak on/off switch. The hole mobility was extracted from the linear part of the subthreshold slope (denoted in the graph by a dashed grey line). **b** Charge carrier mobility values are estimated based on the field-effect characterisation. The mobility values do not show a height-dependent trend and show a few variations around 200 cm<sup>2</sup>/Vs, which fall within the range of the weakly developed in-plane anisotropy in charge transport at room temperature<sup>11</sup>. **c** Electrical conductivity and **d** charge carrier density show a steep increase for flakes with a height below ca. 20 nm (dashed lines as a guide to the eye), whereas, in thicker flakes, the values remain approximately constant. Inset **d** Linear dependence between conductivity and carrier density implies a height-independent average charge carrier mobility of ca. 215 cm<sup>2</sup>/Vs. Error bars result from data acquisition and error propagation in data evaluation.

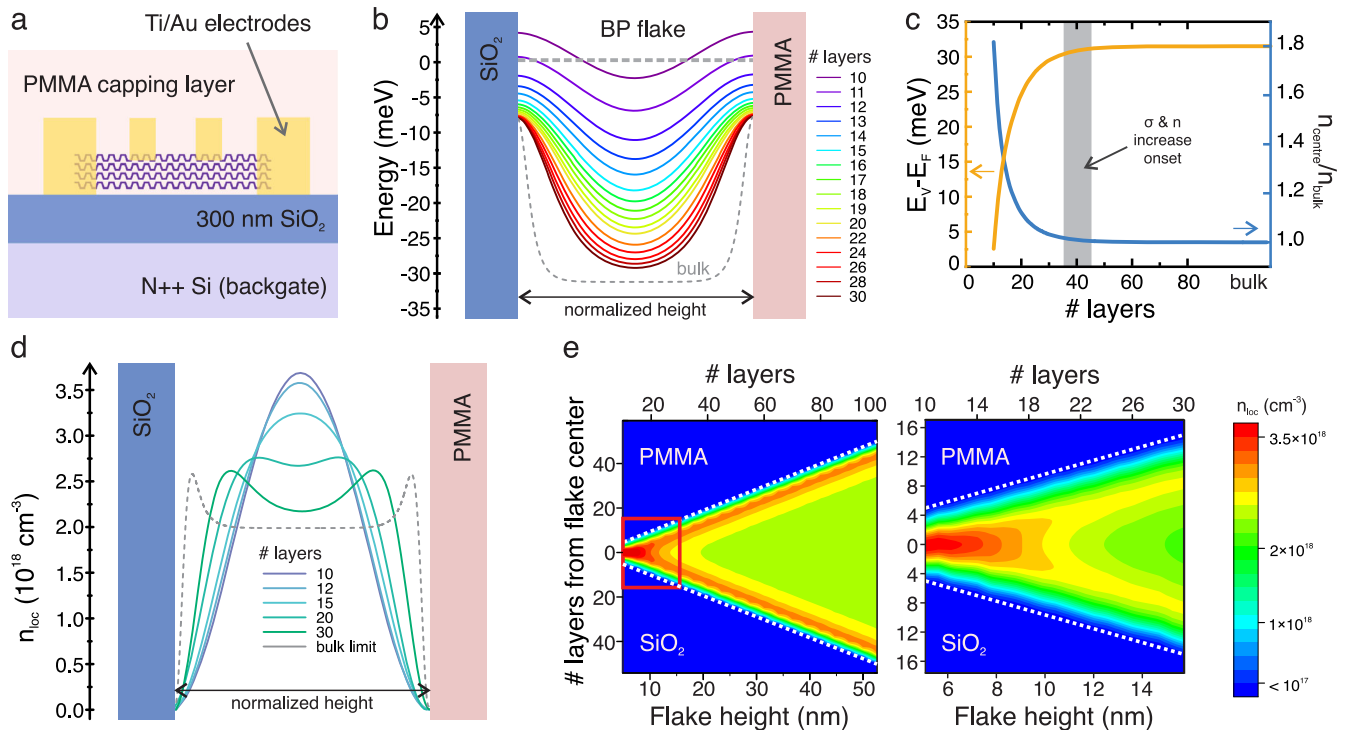
Figure 2c shows the electrical conductivity,  $\sigma$ , as a function of flake height  $h$ . In the case of thicker flakes, the electrical conductivity is relatively constant and of the order of a few tens of S/cm. Notably, a marked increase in  $\sigma$  is observed for flakes with thicknesses below ca. 20 nm, reaching values in the range of 10<sup>2</sup> S/cm. This result is non-trivial, as in the conventional nanoscaled, but still bulk, semiconductor case; one would expect a decrease in conductivity towards smaller layer numbers due to the mere reduction of the cross-sectional area.

Taking the experimentally measured  $\mu$  values into account, we estimated the free mobile charge carrier (hole) density  $n_C$  (Fig. 2d). It needs to be emphasised here that the hole densities of about 1 × 10<sup>18</sup> cm<sup>-3</sup> for our thicker flakes are consistent with recent experimental work on the density of *p*-type vacancies (about 60–63 ppm) in high-quality black phosphorus crystals<sup>10</sup>. For a BP monolayer with an atomic density of 2.53 × 10<sup>15</sup> cm<sup>-2</sup>, it can be therefore estimated that there is only one acceptor-inducing electron trap per several tens of thousands of P atoms in the crystal lattice. This demonstrates the high quality of the BP material used in our study.

Remarkably, we found that  $n_C$ —being the effective density of mobile charge carriers contributing to the electrical conduction—also changes with the number of layers (height). Specifically,  $n_C$  first remains rather constant for thick(er) flakes, while from about 20 nm height on, it displays a continuous increase, reaching values in the range from 5 to 8 × 10<sup>18</sup> cm<sup>-3</sup> for heights in the 10 nm range. Intriguingly, such volume carrier densities in this height range are commonly observed. For instance, a recent publication

by Yan et al.<sup>28</sup> reports on experimental sheet free carrier densities of 5 × 10<sup>12</sup> cm<sup>-2</sup> in a 10 nm high flake; in a similar height range of 8–15 nm, Xia et al.<sup>11</sup> reports on an average sheet carrier density of about 6.7 × 10<sup>12</sup> cm<sup>-2</sup>. Strikingly, these values result in a volume-free carrier density of 5 × 10<sup>18</sup> cm<sup>-3</sup> and 4.5–8.4 × 10<sup>18</sup> cm<sup>-3</sup>, respectively, which falls quantitatively into our experimental values in the same height range. While our experimentally determined hole densities are consistent with other experimental studies, the continuous increase with reduction of height (equivalently layer number) is non-trivial.

The experimental data also reveal that  $\sigma$  is directly proportional to  $n_C$  (inset Fig. 2d), which allows estimating the average charge carrier mobility of (215 ± 49) cm<sup>2</sup>/Vs in all devices. This indicates that a dominant scattering mechanism limiting the motion of the charge carriers exists, which is independent of the layer number and charge carrier density. In fact, recent theoretical<sup>31</sup> and experimental work<sup>32</sup> has shown that the hole mobility in BP flakes is limited exclusively by electron-phonon scattering at room temperature. Specifically, the theoretically expected mobility in monolayer phosphorene at room temperature is about 250 cm<sup>2</sup>/Vs regardless of the carrier density. It should be noted that any ionised charged impurity scattering becomes only dominant at temperatures below 100 K and is at room temperature negligible<sup>32</sup>. Comparison of this value with our experimental (average) mobility suggests, therefore, that indeed, the main scattering contribution of the charge carriers is in-plane electron-phonon scattering; however, also that additional scattering channels exist. These are naturally occurring



**Fig. 3 Space charge region formation and local redistribution of majority charge carriers in multilayer BP close to the flake surfaces.** **a** Schematic diagram depicting an electrically contacted BP multilayer on a  $\text{SiO}_2$  substrate capped with a PMMA protective layer. **b** Valence band energies within BP with layer number varied from 30 to 10. The dashed grey line denotes the VB position expected in bulk BP as a reference. For clarity, the flake heights are normalised as indicated by the double arrow. **c** Layer number dependence of the VB bottom energies (orange) and associated with it the augmentation of local carrier density within the central layers of BP flakes. **d** Examples of local distribution of carriers within BP flakes of different layer numbers (flake heights normalised as in **b**) and **e** the corresponding colour maps depicting local carrier densities within BP flakes as a function of height/layer number. As the layer number is reduced, the majority of charge carriers become confined to the innermost layers. Already for flakes with heights of 10 nm, the free holes are electrically confined into the innermost 1–2 layers, with the carrier-depleted layers not contributing to the charge transport. In all calculations, the average carried density of  $2 \times 10^{18} \text{ cm}^{-3}$  was used.

defects, electronic trapping sites as well as layer-to-layer hopping of free charge carriers.

### Spatial distribution of charge carriers

To elucidate the origin of the observed conductivity and carrier density increase, we first note that due to the presence of a finite charge density between the individual layers<sup>5,6</sup>, the electrical current carrying charges can move both within a single layer and in between neighbouring ones. In a simplified picture, such an electronic system can therefore be treated as a 3D semiconductor with some degree of in-plane preference.

As schematically shown in Fig. 3a, the BP devices in our experiment are bound on each side by insulating  $\text{SiO}_2$  and PMMA, which act both as (rigid) insulating barriers for charge transfer. In nanoscaled systems, such barriers are well known to induce valence and conduction band bending and produce sub-surface space-charge (carrier depletion and accumulation) regions in semiconductor materials<sup>33</sup>.

Consequently, in the case of BP multilayers, the few layers close to the surfaces become depleted of charge carriers and thus do not participate in the overall charge transport<sup>34</sup>. Since typical space-charge regions extend into standard semiconductor bodies by up to a few nm, the impact of surface electrostatics is non-negligible in the case of multilayer BP and, therefore, must be taken into account.

In view of the above complexity, we carried out the self-consistent evaluation of the one-dimensional Schrödinger-Poisson equation<sup>35</sup> to estimate the extent of band bending at the interfaces of BP with  $\text{SiO}_2$  and PMMA perpendicular to the layers (Supplementary Information).

Within our approach, we excluded the contributions from the contact interfaces and flake edges. The one-dimensional description used here was suitable as the lateral dimensions of our flakes are by orders of magnitude larger ( $\mu\text{m}$ ) than our experimental height range (nm). The simulations were carried out for layer numbers ranging from relatively thick, bulk-like >100-layer stacks down to flakes consisting of only 10 layers (ca. 6 nm height—thinnest flakes measured in our study). We also note that we are here outside of the band-gap opening regime for BP. For hole density, we took the experimentally observed average carrier density in thick flakes of about  $2 \times 10^{18} \text{ cm}^{-3}$  in the constant conductivity regime (details on parameters for the model in the Supporting Information). To visualise the impact of space charge formation on the free carrier landscape, we also estimated the spatial distribution of holes across individual flakes. Although the theoretical approach used here is simplistic, it provides not only a qualitative but also a good quantitative description of the multilayer BP system, as shown below.

Figure 3b shows the energetic positions of the valence band (VB) with respect to the Fermi level ( $E_F = 0$ ) and the extent of band bending at the  $\text{SiO}_2/\text{BP}$  and  $\text{BP}/\text{PMMA}$  interfaces for flakes with varying layer numbers (for completeness, bulk-VB is also plotted as a limit of very thick flakes as grey dashed line).

The VB bends upwards at both interfaces, indicating the presence of charge accumulation close to the surfaces. As the flake height is reduced, the VB bottom (corresponding to the central parts of the flakes) is shifted towards the Fermi level, and no flat-band (potential) landscape is observed within the flake centre for flakes with ca. 35–45 layers, which falls close to our experimentally observed onset



of conductivity increase. With further reduction of layer number (below *ca.* 25 layers), also the VB edges at both surfaces move closer to the Fermi level, and for flakes with 10–11 layers (corresponding to the thinnest flakes measured in our study), the VB appears to cross the  $E_F$  close to the flake surfaces.

In Fig. 3c, the distance of the VB bottom (orange line) from  $E_F$  is plotted as a function of layer number. The energetic separation of the VB from the Fermi level is well-known to be intimately connected with the charge carrier density<sup>33</sup>. Based on that, we estimated the effective augmentation of the charge carrier density,  $n_{\text{centre}}/n_{\text{bulk}}$ , in the central layers of the flakes as compared to the corresponding bulk value. As shown in Fig. 3c, we would expect up to a threefold increase in the charge carrier density within the central layers for the thinnest flakes. Remarkably, this is of the same order as observed in our experiments, which further supports the validity of our approach.

For completeness, we had a closer look at the spatial distribution of charge carriers among the layers in individual flakes. Figure 3d shows the (local) spatial distribution,  $n_{\text{loc}}$ , of free charge carriers (holes) in flakes with varied layer numbers. In all cases, there is a distinct carrier depletion region beneath both surfaces of the flakes. For thicker flakes (>75 layers), two narrow charge carrier accumulation layers are formed below the depleted regions, as seen in the ‘rabbit ear’ curve shapes, while the hole density in the central layers remains constant. With height reduction, however, the free charge carriers are squeezed towards the central layers due to the electrostatic potential at the surface, increasing the hole density in the centre. Eventually, for layer numbers below 18, a delta-like dopant profile is observed (Fig. 3e).

Since within the depletion region, the electrical current flow is by large negligible<sup>34</sup>, the findings imply that the charge carriers in the thin BP flakes are spatially limited to the innermost layers only. This effect becomes more prominent for flake heights smaller than about 20 nm, remarkably consistent with our experimental findings that  $\sigma$  and  $n$  suddenly increase (Fig. 2c, d, respectively). In fact, the calculations suggest that for flake heights as large as 10 nm, already only one to two central phosphorene layers are able to carry the electrical current since all mobile charges are confined to these.

This finding is crucial, as it reveals that an electrostatically protected, quasi-2D hole gas confined to only one or two monolayers of phosphorene in the middle of a multilayer flake can be achieved in flakes with about 10 nm height. In particular, it is then this 2D hole gas which carries (predominantly) the electrical current in the entire system. It is worthwhile noting that the confinement of the mobile charge carriers to only one or two layers within the flake does not necessarily imply that these layers experience a bandgap opening, such as isolated monolayer phosphorene<sup>14</sup>. The layers here are still embedded within a larger structure, that is, are subject to the inherent interlayer interactions present in BP. Therefore, the bandgap of these layers to which the 2D hole gas is confined is expected to still have its bulk-value<sup>36,37</sup>.

Remarkably, this (rather simplistic) theoretical divagation reflects the experimentally observed phenomena. Indeed, the development of space-charge regions close to the flake surface can only be possible due to the quasi-3D nature of the BP system. In other words, the combined experimental and model data unequivocally prove the non-pure van der Waals character of interlayer bonding in BP.

Summarising, our findings demonstrate that due to non-negligible interlayer coupling in multilayer BP, an unprecedented increase in the electrical conductivity with decreasing number of layers is found, where the flow of charge carriers is not entirely limited to the constituting monolayers. Consequently, the presence of an insulating environment induces the formation of charge depletion regions extending beneath the flake surfaces.

The observed experimentally drastic increase of electrical conductivity and effective charge carrier density with a reduction of layer number is a natural consequence of the electrostatic confinement of free holes towards the central BP layers. Most notably, already in BP flakes as thick as 10 nm, a naturally encapsulated quasi-2D hole gas can be expected, as the free charge carriers are limited to one or two central layers. This gas should be, by large, protected from external influences and preserve the bulk electronic properties of BP, such as a narrow bandgap. This is further corroborated by the limited layer number and charge-carrier density independent hole mobility at room temperature. Its limitation in this temperature range is associated with electron-phonon scattering<sup>28,29</sup>, and, in particular, its magnitude coincides well with, according to theoretical predictions<sup>29</sup>. Remarkably, we demonstrate that this phenomenon holds at room temperature, which opens the perspective to re-evaluate the use of multilayered BP in particular and comparable multilayered semiconductor materials for on-chip integrated applications in general.

## METHODS

### Sample preparation

BP flakes were mechanically cleaved from high-purity single crystals (2D Semiconductors), transferred onto SiO<sub>2</sub>(300 nm)/Si(*n*+*+*) substrates and then capped with *ca.* 300 nm PMMA. This entire process was carried out under Ar atmosphere within a glove box. Individual flakes covered under PMMA were identified *via* optical means and electrically contacted by standard electron-beam lithography. As electrode material, electron-beam-evaporated Ti/Au (5 nm/50 nm thick) was used. Immediately after fabrication, the devices were capped again by a PMMA layer (*ca.* 300 nm) and baked out.

### Electrical measurements

Electrical measurements were carried out with device-protecting PMMA layer-protected devices on a standard probe station. Driving and gate voltage was applied by K2450 source units. Voltage drops and currents were measured with the aid of K2000 digital multimeters and SR530 current–voltage amplifiers. Both conductivity and mobility were measured by 4-point probing independently. Conductivities were measured with zero gate bias in an open-circuit configuration. All devices were electrically contacted in standard Hall-bar configuration, 2 oppositely oriented source/drain electrodes for the driving voltage and 4 voltage probes in-between (cf. Fig. 1b and inset Fig. 1d). The voltage probes were used to measure the 4-point voltage drop  $V_{4p}$  along the sample when current  $I$  (measured simultaneously) was flowing through the device. The intrinsic conductivity then reads  $\sigma = G_{4p} \frac{L}{wh}$  where  $G_{4p} = \frac{I}{V_{4p}}$ ,  $L$  is the channel length (distance between probing electrodes),  $w$  the channel width (distance between probing electrodes) and  $h$  is the flake height as measured by AFM. The intrinsic 4-point mobility was extracted from the linear (subthreshold) slope of the  $G_{4p}$  vs. backgate voltage  $V_g$  curve using the expression  $\mu = \left| \frac{\partial G_{4p}}{\partial V_g} \right| \frac{L}{w} \frac{t_{ox}}{\epsilon_r \epsilon_0}$  where  $t_{ox} = 300$  nm is the thickness of the SiO<sub>2</sub>,  $\epsilon_r = 3.9$  the dielectric constant of SiO<sub>2</sub> and  $\epsilon_0$  the vacuum permittivity. The carrier density  $n$  was obtained via  $\sigma = en\mu$  where  $e$  is the electron charge. By intrinsic, we refer here to the electronic transport properties as inherent to the real material under study under the given experimental conditions.

### AFM measurements

The height of each flake was determined by a Park Systems NX10 AFM directly after the electrical measurements after stripping the protective PMMA layer.

## Raman microscopy

Raman spectroscopic characterisation was carried out on a Horiba Jobin Yvon LabRAM Aramis confocal Raman microscope (excitation wavelength: 532 nm) with a laser spot size of <math><1\ \mu\text{m}</math> at room temperature. To not compromise the Raman measurements, the spectra were taken without the removal of the device-protecting PMMA layer. No relative position adjustment of the flake and laser beam to account for the in-plane anisotropy of BP was undertaken.

## Schrödinger–Poisson calculations

We used a FreeWare programme available online (<https://www3.nd.edu/gsnider/>) which solves the one-dimensional Poisson and Schrödinger equations self-consistently. We assumed the thickness of both  $\text{SiO}_2$  and PMMA to be 300 nm and varied the thickness of the BP sandwiched between them incrementally layer-by-layer. The physical parameters of the system are listed in Table 1 in the Supplementary Information.

## DATA AVAILABILITY

The data supporting the findings of this study are available within the paper and its Supplementary Information file. Data are also available from the corresponding author upon reasonable request.

## CODE AVAILABILITY

The FreeWare programme we used is available fully online at <https://www3.nd.edu/gsnider/>.

Received: 19 July 2022; Accepted: 10 March 2023;

Published online: 29 March 2023

## REFERENCES

- Xia, F., Wang, H., Hwang, J. C. M., Castro Neto, A. H. & Yang, L. Black phosphorus and its isoelectronic materials. *Nat. Rev. Phys.* **1**, 306–317 (2019).
- McCreary, A., Kazakova, O., Jariwala, D. & Al Balushi, Z. Y. An outlook into the flat land of 2D materials beyond graphene: synthesis, properties and device applications. *2D Mater.* **8**, 013001 (2008).
- Ajayan, P., Kim, P. & Banerjee, K. Two dimensional van der Waals materials. *Phys. Today* **69**, 38 (2016).
- Keyes, R. W. The electrical properties of black phosphorus. *Phys. Rev.* **92**, 580–584 (1953).
- Qiao, J., Kong, X., Hu, Z.-X., Yang, F. & Ji W. High-mobility transport anisotropy and linear dichroism in few-layer black phosphorus. *Nat. Commun.* **5**, 4475 (2014).
- Shulenburg, L., Baczewski, A. D., Zhu, Z., Guan, J. & Tomanek, D. The nature of the interlayer interaction in bulk and few-layer phosphorus. *Nano Lett.* **15**, 8170–8175 (2015).
- Warschauer, D. Electrical and optical properties of crystalline black phosphorus. *J. Appl. Phys.* **34**, 1853 (1963).
- Tao, J. et al. Mechanical and electrical anisotropy of few-layer black phosphorus. *ACS Nano* **9**, 11362–11370 (2015).
- Xiang, D. et al. Surface transfer doping induced effective modulation on ambipolar characteristics of few-layer black phosphorus. *Nat. Commun.* **6**, 6485 (2015).
- Riffle, J. V. et al. Impact of vacancies on electronic properties of black phosphorus probed by STM. *J. Appl. Phys.* **123**, 044301 (2018).
- Xia, F., Wang, H. & Jia, Y. Rediscovering black phosphorus as an anisotropic layered material for optoelectronics and electronics. *Nat. Commun.* **5**, 4458 (2014).
- Liu, H., Du, Y., Deng, Y. & Ye, P. D. Semiconducting black phosphorus: synthesis, transport properties and electronic applications. *Chem. Soc. Rev.* **44**, 2732–2743 (2015).
- Carvalho et al. Phosphorene: from theory to applications. *Nat. Rev. Mater.* **1**, 16061 (2016).
- Xiao, J. et al. Theoretical predictions on the electronic structure and charge carrier mobility in 2D Phosphorus sheets. *Sci. Rep.* **5**, 09961 (2015).
- Long, G. et al. Achieving ultrahigh carrier mobility in two-dimensional hole gas of black phosphorus. *Nano Lett.* **16**, 7768–7773 (2016).
- Yi, Y., Sun, Z., Li, J., Chu, P. K. & Yu, X.-F. Optical and optoelectronic properties of black phosphorus and recent photonic and optoelectronic applications. *Small Methods* **3**, 1900165 (2019).
- Huang, L. et al. Waveguide-integrated black phosphorus photodetector for mid-infrared applications. *ACS Nano* **13**, 913–921 (2019).
- Li, B. et al. Black phosphorus, a rising star 2D nanomaterial in the post-graphene era: synthesis, properties, modifications, and photocatalysis applications. *Small* **15**, 1804565 (2019).
- Pang, J. et al. Applications of phosphorene and black phosphorus in energy conversion and storage devices. *Adv. Energy Mater.* **8**, 1702093 (2018).
- Qiu, M. et al. Current progress in black phosphorus materials and their application in electrochemical energy storage. *Nanoscale* **9**, 13384–13403 (2017).
- Luo, M., Fan, T., Zhou, Y., Zhang, H. & Mei, L. 2D black phosphorus-based biomedical applications. *Adv. Funct. Mater.* **29**, 1808306 (2019).
- Wang, G. et al. Introduction of interfacial charges to black phosphorus for a family of planar devices. *Nano Lett.* **16**, 6870–6878 (2016).
- Yasaie, P. et al. High-quality black phosphorus atomic layers by liquid-phase exfoliation. *Adv. Mater.* **27**, 1887–1892 (2015).
- Liu, H. et al. Phosphorene: an unexplored 2D semiconductor with a high hole mobility. *ACS Nano* **8**, 4033–4041 (2014).
- Kang, J. et al. Solvent exfoliation of electronic-grade two-dimensional black phosphorus. *ACS Nano* **9**, 3596–3604 (2015).
- Kaneta, C., Katayama-Yoshida, H. & Morita, A. Lattice dynamics of black phosphorus. *Solid State Commun.* **44**, 613–617 (1982).
- Morita, A. Semiconducting black phosphorus. *Appl. Phys. A* **39**, 227–242 (1986).
- Ribeiro, H. B., Pimenta, M. A. & de Mátosa, C. J. S. Raman spectroscopy in black phosphorus. *J. Raman Spectrosc.* **49**, 76–90 (2018).
- Ziletti, A., Carvalho, A., Campbell, D. K., Coker, D. F. & Castro Neto, A. H. Oxygen defects in phosphorene. *Phys. Rev. Lett.* **114**, 046801 (2015).
- Koenig, S. P., Doganov, R. A., Schmidt, H., Castro Neto, A. H. & Özyilmaz, B. Electric field effect in ultrathin black phosphorus. *Appl. Phys. Lett.* **104**, 103106 (2014).
- Rudenko, A. N., Brener, S. & Katsnelson, M. I. Intrinsic charge carrier mobility in single-layer black phosphorus. *Phys. Rev. Lett.* **116**, 246401 (2016).
- Yan, X., Wang, H. & Esqueda, I. S. Temperature-dependent transport in ultrathin black phosphorus field-effect transistors. *Nano Lett.* **19**, 482–487 (2019).
- Simpkins, B. S., Mastro, M. A., Eddy, C. R. Jr. & Pehrsson, P. E. Surface depletion effects in semiconducting nanowires. *J. Appl. Phys.* **103**, 104313 (2008).
- Calarco, R., Stoica, T., Brandt, O. & Geelhaar, L. Surface-induced effects in GaN nanowires. *J. Mater. Res.* **26**, 2157–2168 (2011).
- Snider, G. L., Tan, I.-H. & Hu, E. L. Electron states in mesa-etched one-dimensional quantum well wires. *J. Appl. Phys.* **68**, 2849 (1990).
- Tian, T. et al. Electronic polarizability as the fundamental variable in the dielectric properties of two-dimensional materials. *Nano Lett.* **20**, 841–851 (2020).
- Tan, I.-H., Snider, G. L. & Hu, E. L. A self consistent solution of Schroedinger-Poisson equations using a nonuniform mesh. *J. Appl. Phys.* **68**, 4071 (1990).

## ACKNOWLEDGEMENTS

V.K. and A.H. acknowledge support by the Deutsche Forschungsgemeinschaft (DFG) through the project “Elektronische Bauelemente auf Basis des 2D-Materials schwarzer Phosphor—lagenanzahlabhängige Eigenschaften” (grant No. KR 2264/7-1 and HU 2827/2-1, respectively). The work was supported by the European Union (ERC Advanced Grant 742145 B-PhosphoChem to A. Hirsch, ERC-2018-StG 804110-2D-PnictoChem to G.A.). G.A. acknowledges the DFG (FLAG-ERA AB694/2-1) the Spanish MICINN (PID2019-111742GA-I00, “María de Maeztu” Programme for Units of Excellence in R&D CEX2019-000919-M) and the Generalitat Valenciana (CIDEAGENT/2018/001).

## AUTHOR CONTRIBUTIONS

V.K. designed and supervised the study. M.K.G., L.M., T.U. and M.S. carried out device preparation, electrical characterisation, and AFM measurements. M.S. performed the Raman measurements and G.E. the numerical simulations. T.H., A.H., J.S., M.N., M.Sz. and M.K.G. did AFM measurements and analysis. G.A., S.W., V.L., U.M., M.R., F.H. and A.Hi. carried out the flake preparation. M.K.G. and V.K. analysed the data. All authors contributed equally to the paper write-up.

## FUNDING

Open Access funding enabled and organized by Projekt DEAL.

## COMPETING INTERESTS

The authors declare no competing interests.

## INCLUSION AND ETHICS

This research study has included local researchers throughout the research process with well-defined responsibilities. The research presented is locally relevant and is due to a profound collaboration of the local partners.

## ADDITIONAL INFORMATION

**Supplementary information** The online version contains supplementary material available at <https://doi.org/10.1038/s41699-023-00384-2>.

**Correspondence** and requests for materials should be addressed to Vojislav Krstić.

**Reprints and permission information** is available at <http://www.nature.com/reprints>

**Publisher's note** Springer Nature remains neutral with regard to jurisdictional claims in published maps and institutional affiliations.



**Open Access** This article is licensed under a Creative Commons Attribution 4.0 International License, which permits use, sharing, adaptation, distribution and reproduction in any medium or format, as long as you give appropriate credit to the original author(s) and the source, provide a link to the Creative Commons license, and indicate if changes were made. The images or other third party material in this article are included in the article's Creative Commons license, unless indicated otherwise in a credit line to the material. If material is not included in the article's Creative Commons license and your intended use is not permitted by statutory regulation or exceeds the permitted use, you will need to obtain permission directly from the copyright holder. To view a copy of this license, visit <http://creativecommons.org/licenses/by/4.0/>.

© The Author(s) 2023